

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: S. MOTOWAKI, et al.  
Serial No: 10/801,579  
Filed: MARCH 17, 2004  
Title: NANOPRINT EQUIPMENT AND METHOD OF MAKING FINE  
STRUCTURE  
Group AU: 1722  
Examiner: Emmanuel S. Luk  
Confirm. No : 2747

**AMENDMENT**

**Mail Stop: AMEND - FEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 23, 2007

Sir:

In response to the Office Action mailed February 23, 2007, the period for response having been extended for three (3) months by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.